



# EU Compound Semiconductor Committee Meeting Summary and Minutes

SEMICON Europa 9<sup>th</sup>, October 2013, 11.30am-1pm Messe Dresden, Dresden, Germany

#### **Next Committee Meeting:**

April 2014, Nuremberg, Germany - Exact date to be confirmed in early 2014

**Committee Announcements (optional)** None

#### **Table 1 Meeting Attendees**

**Co-Chairs:** Arnd-Dietrich Weber (SiCrystal AG) **SEMI Staff:** Yann Guillou

Company	Last	First	Company	Last	First
SemiMap	Jantz	Wolfgang			
Self	Wagner	Peter			
Freiberger Compound Mater	Kretzer	Ulrich			

#### **Table 2 Leadership Changes**

Group	Previous Leader	New Leader
None		

#### Table 3 Ballot Results (or move to Section 4, Ballot Review)

**Passed** ballots and line items will be submitted to the ISC Audit & Review Subcommittee for procedural review. **Failed** ballots and line items were returned to the originating task forces for re-work and re-balloting.

Document #	Document Title	Committee Action	
None			

#### Table 4 Authorized Ballots (or move to Section 7, New Business)

#	When	SC/TF/WG	Details
5370	Cycle 8	SiC Material and Wafer Specification	Specification for 150mm Silicon Carbide single-crystalline substrates

#### Table 5 Authorized Activities (or move to Section 7, New Business)

#	Туре	SC/TF/WG	Details
None			

Note: SNARFs and TFOFs are available for review on the SEMI Web site at: <a href="http://downloads.semi.org/web/wstdsbal.nsf/TFOFSNARF">http://downloads.semi.org/web/wstdsbal.nsf/TFOFSNARF</a>





#### Table 6 New Action Items (or move to Section 8, Action Item Review)

	Item #	Assigned to	Details
1	1	Yann Guillou	Write minutes of previous meeting and share them with Arnd-Dietrich Weber
2 Yann Guillou Send M55 standard document to Arnd-Dietrich Weber			

# 1 Welcome, Reminders, and Introductions

Arnd –Dietrich Weber called the meeting to order at 11.30am. The meeting reminders on antitrust issues, intellectual property issues and holding meetings with international attendance were reviewed. Attendees introduced themselves.

# 2 Review of Previous Meeting Minutes

The committee was not able to review the minutes of the previous meeting as they were missing. Yann Guillou took the action to prepare and send them to Arnd-Dietrich Weber.

# 3 Liaison Reports

3.1 Japan Compound Semiconductor Committee

Yann Guillou reported for the Japan Committee.

Attachment: 1, JP\_Compound\_NA Spring 2012\_R1.0

#### 3.2 NA Compound Semiconductor Committee

Yann Guillou reported for the NA Compound Semiconductor Committee.

Attachment: 2, NA CSM report October 2013 MT

# 3.3 SEMI Staff Report

Yann Guillou gave the SEMI Staff Report.

Attachment: 3, SEMI Staff Report (Europa 2013) rev5



#### 4 Ballot Review

None

# 5 Subcommittee & Task Force Reports

5.1 Contactless Capacitive Resistivity

Wolfgang Jantz reported for the Contactless Capacitive Resistivity Task Force.

He mentioned the document structure and writing was on-going. A meeting shall be planned in 2014 to progress and try to finalize a document.

# 5.2 SiC 100/150mm

Arnd-Dietrich Weber reported for the SiC 100/150mm Task Force.

He mentioned the IP review of doc #5370 was done by the TF. He informed the TC the TF pass the motion to propose the doc #5370 for balloting at the TC meeting.

Arnd-Dietrich presented the document to TC attendees and collected their feedbacks.

# 6 Authorized Ballot

6.1 Doc #5370: Specification for 150mm Silicon Carbide single-crystalline substrates

Motion:	Doc #5370 to be submitted for ballot in cycle 8 and be adjudicated at next meeting scheduled in April 2014 in Nuremberg
By / 2 <sup>nd</sup> :	Wolfgang Jantz / Peter Wagner
Discussion:	Some discussion about the reference to M55. TC chair will review this with HQ staff
Vote:	4/0

# 7 Action Item Review

# 7.1 Open Action Items

Due to the missing on the previous meeting minutes, open action items were not reviewed.

8.2 New Action Items

Yann Guillou reviewed the new action items. These can be found in the New Action Items table at the beginning of these minutes.

# 8 Next Meeting and Adjournment

The next meeting of the EU Compound Semiconductor committee is scheduled for April 2014 in Nuremberg. Exact meeting date and details about the meeting venue will be shared by beginning of 2014.







Respectfully submitted by: Yann Guillou SEMI Europe Phone: +33 4 38 78 39 71 Email: yguillou@semi.org

Minutes approved by:	
Arnd-Dietrich Weber (SiCrystal), Co-chair	Jan 7 <sup>th</sup> , 2014

# Table 7 Index of Available Attachments #1

#	Title	#	Title
1	1 JP_Compound_NA Spring 2012_R1.0		
2	NA CSM report October 2013 MT		
3 SEMI Staff Report (Europa 2013) rev5			

#1 Due to file size and delivery issues, attachments must be downloaded separately. A .zip file containing all attachments for these minutes is available at www.semi.org. For additional information or to obtain individual attachments, please contact [SEMI Staff Name] at the contact information above.